

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	DAVID J. BAIN, ET AL.)	
)	Group Art Unit: 2836
Serial No.:	10/710,653)	
)	
Filed:	July 27, 2004)	Examiner: Roman, L.
)	
For:	PRESSURE ASSISTED WAFER)	
	HOLDING APPARATUS AND)	Confirmation No.: 4652
	CONTROL METHOD)	

RESPONSE AFTER FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In response to the Final Office Action mailed August 22, 2007, the Applicants submit the following remarks: